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REPORT DOCUMENTATION PAGE

Förm Approved
OMB No. 0704-0188

Public reporting burden for this collection of information is estimated to average 1 hour per response, including the time for reviewing instructions, searching existing data sources, gathering and maintaining the data needed, and completing and reviewing the collection of information. Send comments regarding this burden estimate or any other aspect of this collection of information, including suggestions for reducing this burden, it washington Headquarters Services, Directorate for information Operations and Reports, 1218 Jefferson Davis nighway, Suite 1204, Arlington, VA 22202-4302, and to the Office of Management and Budget, Paperwork Reduction Project (0704-0188), Washington, DC 20503.

1. AGENCY USE ONLY (Leave blank)

2. REPORT DATE

April 25, 1995

3. REPORT TYPE AND DATES COVERED

Final Technical/Oct 15, '94-Feb 28, '95

4. TITLE AND SUBTITLE

Rapid Thermal:Processing of semiconductors at High Vapor Densitys

5. FUNDING NUMBERS F49620-94-1-0447

6. AUTHOR(S)

H.T. Banks

AFOSR-IR- 95 - 0435

7. PERFORMING ORGANIZATION NAME(S) AND ADDRESS(ES)

Center for Research In Scientific Computation North Carolina State University Box 8205 Raleigh, NC 27695-8205 B. PERFORMING ORGANIZATION REPORT NUMBER

9. SPONSORING/MONITORING AGENCY NAME(S) AND ADDRESS(ES)

AFOSR/NM 110 Duncan Ave., Suite Bl15 Bolling AFB, DC 20332-0001 10. SPONSORING/MONITORING AGENCY REPORT NUMBER

11. SUPPLEMENTARY NOTES



12a. DISTRIBUTION / AVAILABILITY STATEMENT

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126. DISTRIBUTION CODE

13. ABSTRACT (Maximum 200 words)

The fluid dynamics in a vertical reactor for high pressure vapor transport (HPVT) of compound semiconductors is modeled. The modeling is for the growth of II-IV-V₂ chalcopyrite ZnGeP₂ and addresses the flow of dense phosphorus gas at 3.42X10⁵ Pascals pressure. Effects of density variations on p-polarized reflectance spectroscopy are also examined. The mathematical model for transport processes is described by the full gasdynamic equations (Navier Stokes equations coupled with an equation for energy). In addition, buoyancy effects are included in the model through the gravitational term in the momentum equation. Numerical results of a 3-D steady flow are presented using a finite element discretization with non-uniform, quadrilateral elements. The numerical simulations were performed to study the effects of gravitational-induced buoyancy-driven cenvection flows in HPVT crystal growth.

14. SUBJECT TERMS

15. NUMBER OF PAGES

16. PRICE CODE

17. SECURITY CLASSIFICATION OF REPORT 8. SECURITY CLASSIFICATION OF THIS PAGE 19. SECURITY CLASSIFICATION OF ABSTRACT

20. LIMITATION OF ABSTRACT

NSN 7540-01-280-5500

DITO QUALITY INSPRICTED 1

Standard Form 298 (Rev. 2-89) Prescribed by Ansi Std. 239-18 298-102

Final Technical Report on the grant

AFOSR F49620-94-1-0447

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North Carolina State University

for the period

October 15, 1994 - February 28, 1995

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Report prepared by

H.T. Banks

April 25, 1995

GRANT AMENDMENT

UNITED STATES AIR FORCE

AIR FORCE OFFICE OF SCIENTIFIC RESEARCH BUILDING 410, BOLLING AFB, D. C. 20332-6448

GRANT NO. AMEND EFF	ECTIVE DATE	PURCHASE REQUEST NO.	I	PROJECT-TASK		
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GRANTEE			1	AUTHORITY 10 U.S.C. 2358		
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NEGOTIATOR (Name, Organization, Telephone No.) CARMEN CALVERT/PKA (202) 767-4943		PROGRAM MANAGER (Name, C DR. MARC Q. (202) 767-50		retephone Na.) NM		
ACCOUNTING AND APPROPRIATION DATA						

N/A

THE GRANT IDENTIFICATION ABOVE IS MODIFIED AS FOLLOWS:

By changing the duration from 1 to 5.5 months and establishing an expiration date of 28 Feb 95.

The final reporting requirements are revised as shown below and shall be submitted on the dates and in the quantities shown below:

REPORTS	PERIOD COVERED	DUE DATE	SUBMIT TO	OF COPIES
Final Technical	15 Sep 94 - 28 Feb 95	30 Apr 95	AFOSR/NM	6
Final Invention	15 Sep 94 - 28 Feb 95	30 Apr 95	AFOSR/JA	3
Final Fiscal	15 Sep 94 - 28 Feb 95	31 May 95	AFOSR/PKA	2

EXCEPT AS PROVIDED WHEREIN, ALL TERMS AND CONDITIONS OF THE GRANT, AS HERETOFORE CHANGED, REMAIN UNCHANGED AND IN FULL FORCE AND EFFECT.

FOR THE GRANTEE	FOR THE UNITED STATES OF AMERICA	
SIGNATURE OF PERSON AUTHORIZED TO SIGN	SIGNATURE OF CONTRACTING OFFICER	
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Coordinator Centers FEB 2 2 1995	Administrative Contracting Officer	DMarg-

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Research Activity Summary

This grant was initially for one month (Oct. 15-Nov. 14, 1994) with the expectation of a 12 month additional funding period. The additional 12 month funding was delayed and a no-cost extension was granted to permit the effort to continue.

In spite of a shortfall in funding, substantial progress on the initial phase of this work was achieved. Several postdoctoral associates were hired and training began. Three papers (the abstracts are appended as part of this report) were produced by February, 1995.

We have made an excellent start and anticipate we will be able to achieve the original proposed research goals if the additional 12 month funding is forthcoming.

Heteroepitaxy of Lattice-Matched Compound Semiconductors on Silicon

Klaus J. Bachmann^{a,b}, Nikolaus Dietz^a, Amy E. Miller^a, David Venables^a and James T. Kelliher^a

Department of Materials Science and Engineering^a
and Department of Chemical Engineering^b
North Carolina State University, Raleigh, North Carolina 27695-7919

Abstract

The heteroepitaxial overgrowth of silicon by nearly lattice matched compound semiconductors is reviewed in the context of the separation of the chemical problems associated with the initial sealing of the silicon surface by a contiguous epitaxial compound film from the problems associated with the generation of strain during heteroepitaxial growth. Of the mixed compound systems available dilute solid solutions of composition Al_xGa_{1-x}N_yP_{1-y} and ZnS_ySe_{1-y} as well as ZnSi_xGe_{1-x}P are suitable candidates for the exactly lattice-matched epitaxial overgrowth of silicon. Real-time process monitoring by non-intrusive methods is important for gaining an understanding of the epitaxial overgrowth mechanism and for controlling the film properties. A new method, p-polarized reflectance spectroscopy (PRS) is introduced that provides detailed information about the growth rate per cycle, the bulk optical properties of the film and its topography. Sub-monolayer resolution is accomplished for thousands of Å of film growth by pulsed chemical beam epitaxy (PCBE). While the cubic materials choices considered here generally afford easier control of the electrical and optical properties, the non-cubic materials have advantages in the sealing of the silicon surface because of their anisotropic growth and the formation of metastable solid solutions that may permit the graded growth of compound films under exactly lattice-matched conditions. Therefore, no clear cut preference in the materials selection for nearly lattice-matched overgrowth of silicon by compound semiconductors can be identified at this time.

HIGH PRESSURE VAPOR TRANSPORT OF ZnGeP₂: I. PARAMETER EVALUATION

S. Fiechter scg Cds mail. hmr.de
Hahn-Meitner-Institut
Department of Physical Chemistry
Glienicker Strasse 100, D-14109 Berlin

R. H. Castleberry, N. Dietz and K. J. Bachmann Department of Materials Science and Engineering

H. T. Banks, K. Ito, J. S. Scroggs and Hien Tran
Department of Mathematics
North Carolina State University, Raleigh, North Carolina

Abstract

ZnGeP₂ crystals and epilayers can be grown by chemical vapor transport using phosphorus or hydrogen chloride as transporting agent. The limiting factor in the transport rate is the volatility of germanium which has a seven order of magnitude smaller partial pressure than elemental zinc. Excluding oxygen using carbon films inside the growth vessels and employing a nitrogen shroud in the furnace tube also transport of ZnGeP₂ will be obtained when phosphorus is used as transport agent. Optical absorption measurements above show the presence of absorption band head systems which cannot be explained by the absorption lines of P₂, P₄, PO or GeO. These new bands are also present in the vapor above ZnGeP₂ but not above ZnP₂. The experimental findings have been simulated by thermochemical calculations taking into account estimated values for the vapor species GeP.

l. Introduction

ZnGeP₂ crystallizes in the chalcopyrite structure which can be inferred from the zincblende lattice by doubling the unit cell of ZnS and ordering the cation sublattice. In the tetragonal unit cell a small distortion occurs in the direction of the c-axis which substantially affects the optical properties of this compound semiconductor. The material is of interest in context of its non-linear optical properpties and can be applied as optical parametric oscillator or for frequency mixing. For this reason, thick films or crystals of high transparency are in demand, which can be grown from the vapor phase.

The dissociation pressure of the ternary chalcopyrite $ZnGeP_2$ amounts to 3.5 bars at the melting point at 1295 K [2]. In the last contribution to this conference series [1] we directed attention to the sensitive change of this equilibrium pressure with composition of the condensed phase. Therefore, close control of the partial pressures of the constituting elements and their gaseous compounds during vapor growth is necessary.

In this paper we discuss vapor phase transport experiments of ZnGeP₂ in oxygen free environment using phosphorus or hydrogen chloride as transport agent. It is assumed that germanium as well as zinc could form volatile phosphorus species. To detect new phosphorus bearing gas species, optical absorption spectroscopy of the vapor phases over ZnGeP₂, ZnP₂ and GeP has been performed. The results are compared with thermochemical calculations using the free energy minimization method described by Ericson [3].

II. Transport Experiments

In order to distinguish the conditions of multiphase from those for single phase transport under exclusion of deleterious effects of residual oxygen contamination of the vapor atmosphere experiments

HIGH PRESSURE VAPOR TRANSPORT OF ZnGeP₂: II. THREE-DIMENSIONAL SIMULATION OF GASDYNAMICS UNDER MICROGRAVITY CONDITIONS ^{1 2}

J. S. Scroggs, H. T. Banks, K. Ito, S. Ravindran, and H. T. Tran

Center for Research in Scientific Computation

Department of Mathematics

North Carolina State University

Raleigh, NC, USA

and

K.J. Bachmann, H. Castleberry, N. Dietz Department of Materials Science and Engineering North Carolina State University Raleigh, NC, USA

Abstract

The fluid dynamics in a vertical reactor for high pressure vapor transport (HPVT) of compound semiconductors is modeled. The modeling is for the growth of II-IV-V₂ chalcopyrite ZnGeP₂ and addresses the flow of dense phosphorus gas at 3.42×10^5 Pascals pressure. Effects of density variations on p-polarized reflectance spectroscopy are also examined. The mathematical model for transport processes is described by the full gasdynamic equations (Navier Stokes equations coupled with an equation for energy). In addition, buoyancy effects are included in the model through the gravitational term in the momentum equation. Numerical results of a 3-D steady flow are presented using a finite element discretization with non-uniform, quadrilateral elements. The numerical simulations were performed to study the effects of gravitational-induced buoyancy-driven convection flows in HPVT crystal growth.

Introduction

Non-linear optical interactions in birefringent materials find applications in phase-matched harmonic generation and frequency mixing. In particular, ZnGeP₂, which has a high non-linear susceptibility coefficient, has been used for manu-